

PATENT
Attorney Docket No. 7363.0010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of:

U.S. Patent No.: 5,792,261

Inventor: Kiichi HAMA et al.

Issued: August 11, 1998

Serial No.: 09/478,370

Filed: January 6, 2000

For: PLASMA PROCESS
APPARATUS

Group Art Unit: 1763

Examiner: Alejandro Mulero, L.

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

PETITION TO REVIVE AN UNINTENTIONALLY ABANDONED APPLICATION

In accordance with 37 C.F.R. § 1.137(b), applicant petitions the Commissioner to revive this reissue application, which went abandoned on September 27, 2001, due to applicant's unintentional failure to file a Request for Continued Examination (RCE) to keep this case alive beyond September 27, 2001 following an Advisory Action mailed September 20, 2001.

Enclosed with this petition is the required reply, an RCE, including the requested response to the Final Office Action of March 27, 2001, and the petition fee as set forth in 37 C.F.R. § 1.17(m) of \$1,280.

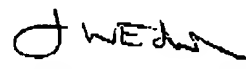
In accordance with 37 C.F.R. § 1.137(b)(3), applicant states that the entire delay in filing the required reply from the due date for the reply (September 27, 2001), until the filing date of this petition, was unintentional.

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If there are any additional fees due in connection with the filing of this response,
please charge them to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: 
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Date: October 11, 2001

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